

<b>Notice of References Cited</b>	Application/Control No. 10/593,848		Applicant(s)/Patent Under Reexamination LEE ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2004/0264963	12-2004	Kani et al.	398/072
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	D	US-			
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	F	US-			
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*	N	WO 03055111 A1	07-2003	World Intellect	TERVONEN et al.	
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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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